

501.34189R00 / 329500233US02M

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

A. NAKAMURA et al.

Application No.:

09/613,541

Filed:

July 7, 2000

For:

SEMICONDUCTOR DEVICE HAVING AN IMPROVED

CONNECTION ARRANGEMENT BETWEEN A

SEMICONDUCTOR PELLET AND BASE SUBSTRATE

ELECTRODES (As Amended)

**Art Unit:** 

2826

Examiner:

A. Williams

Conf. No.:

9061

## **AMENDMENT**

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

7 April 2005

Sir:

In response to the Office Action dated 27 January 2005, the following is respectfully submitted in connection with the above-identified application.

In accordance with 37 CFR §1.121 in the Final Rule effective 30 July 2003, and as revised in the Final Rule effective 21 October 2004, each section of amendment begins on a new page, and changes are shown by strike-through (or double brackets where appropriate) and underlining to indicate deletions and additions, respectively. A complete listing of all claims ever presented in the application is given with the current status of each claim, and only the text of all pending and withdrawn claims is presented in full, with those pending/withdrawn claims not being amended herein being presented in clean version.